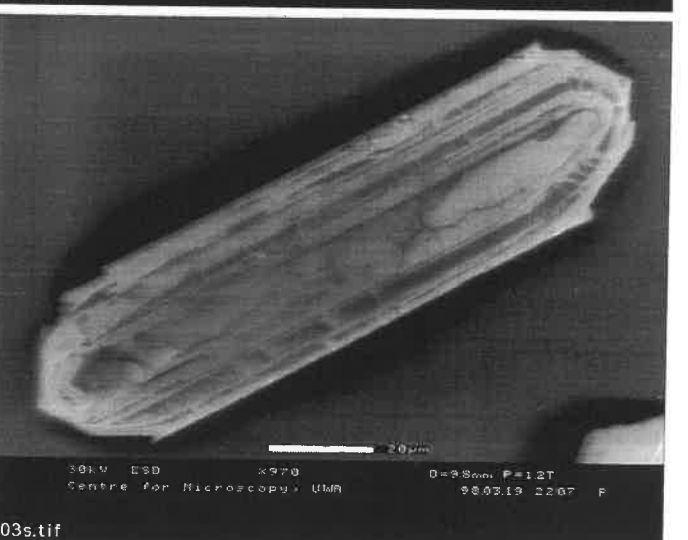
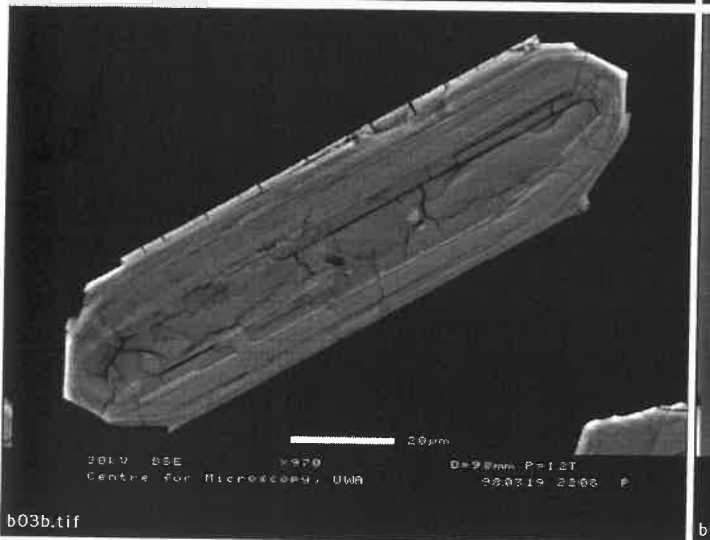
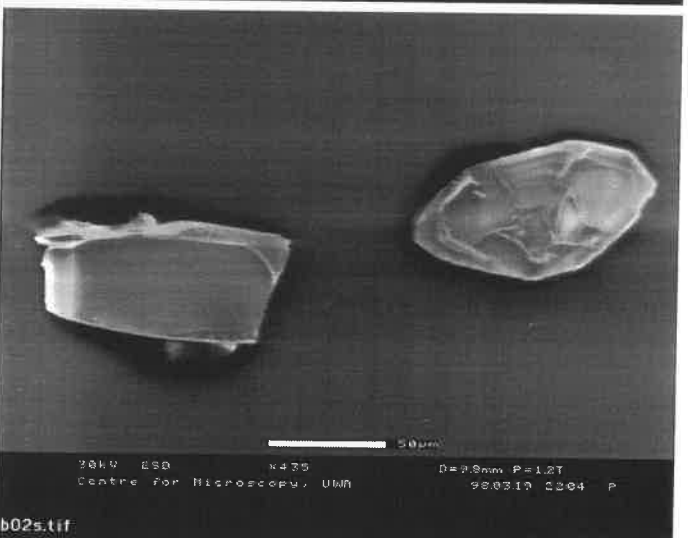
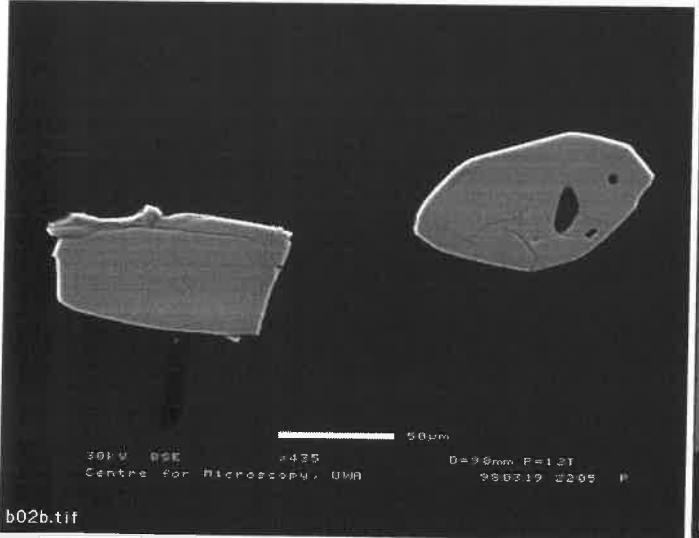
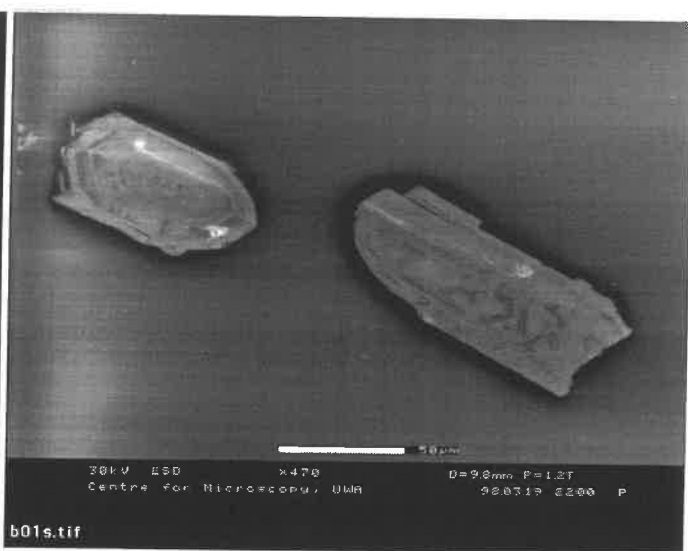
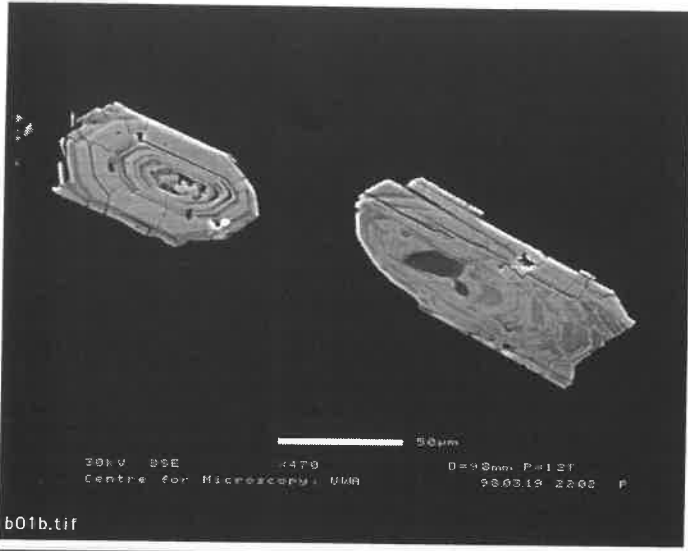
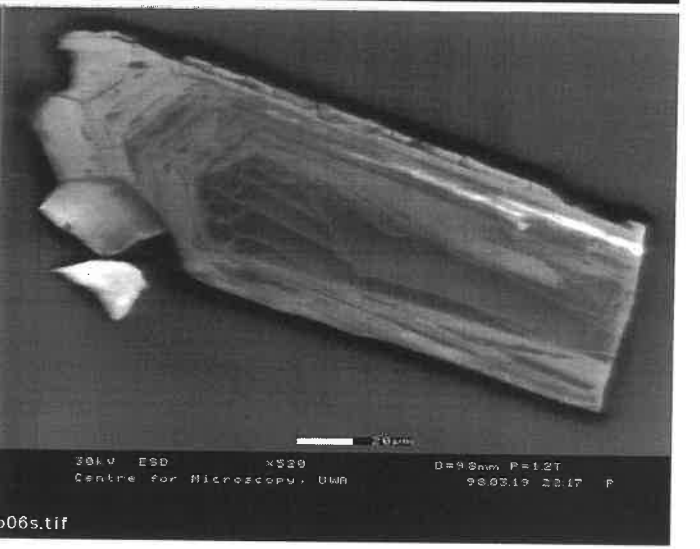
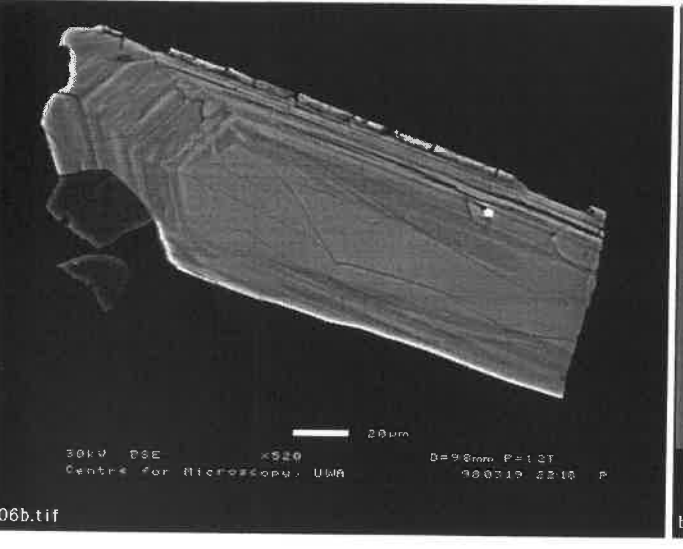
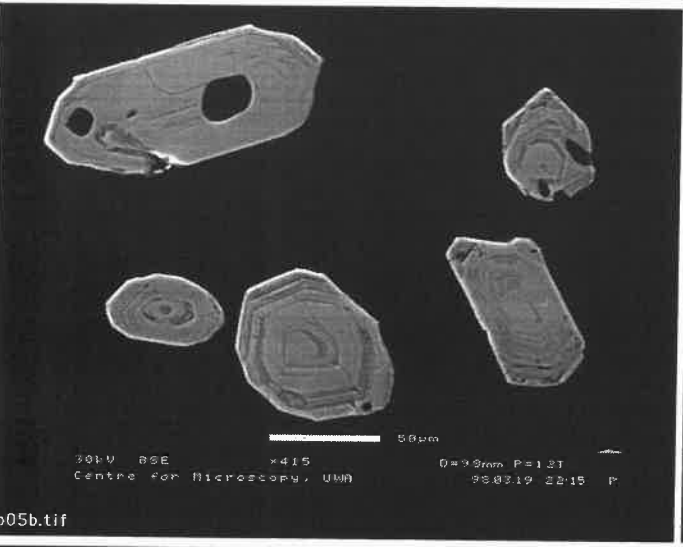
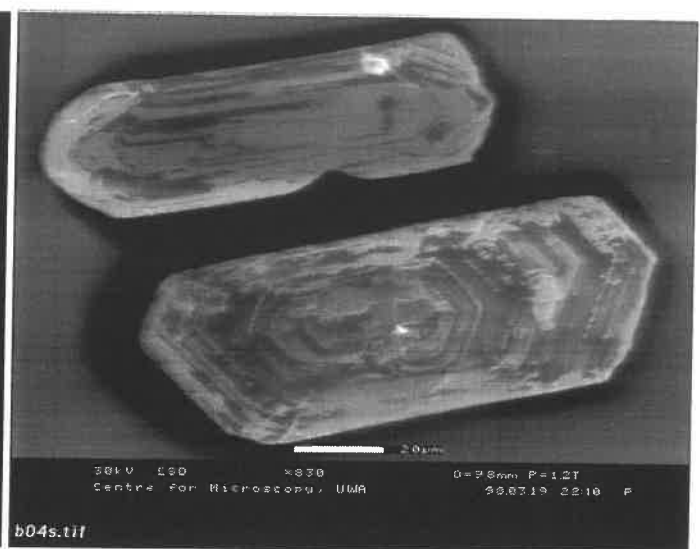
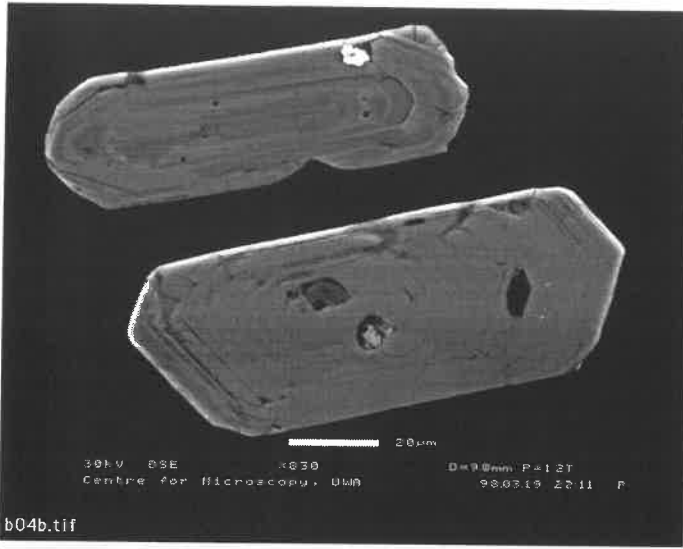


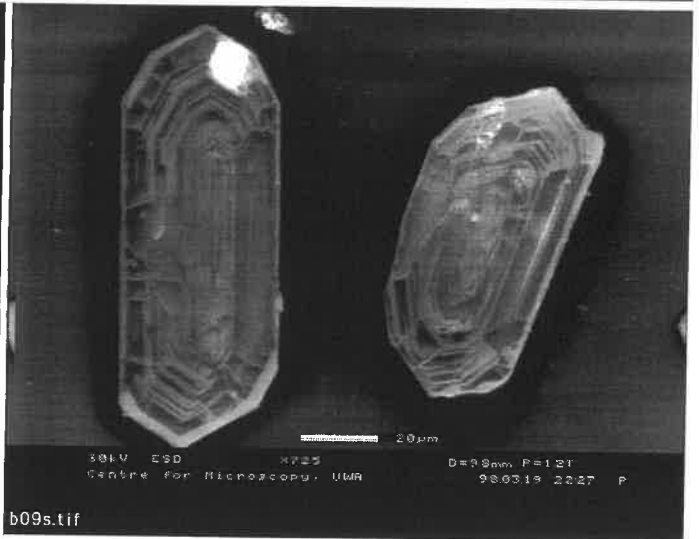
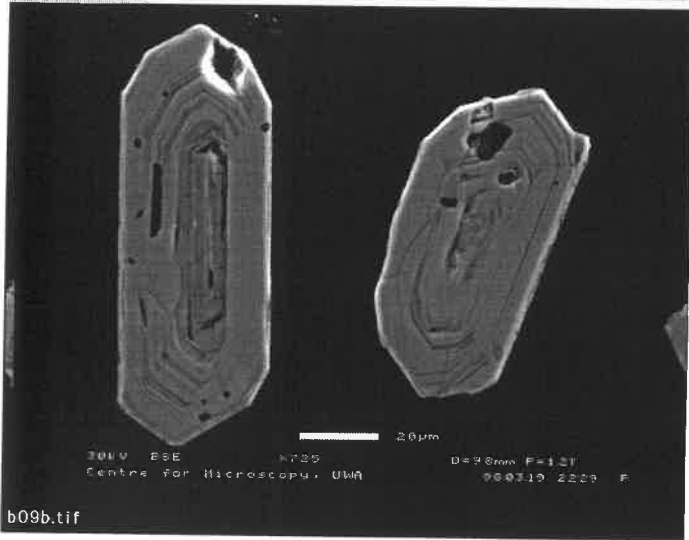
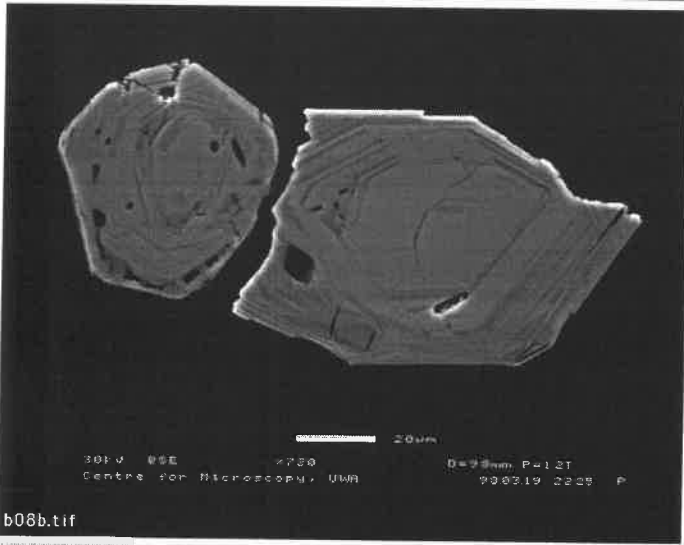
Mount 97-40, Population B (1) 20. 3.98



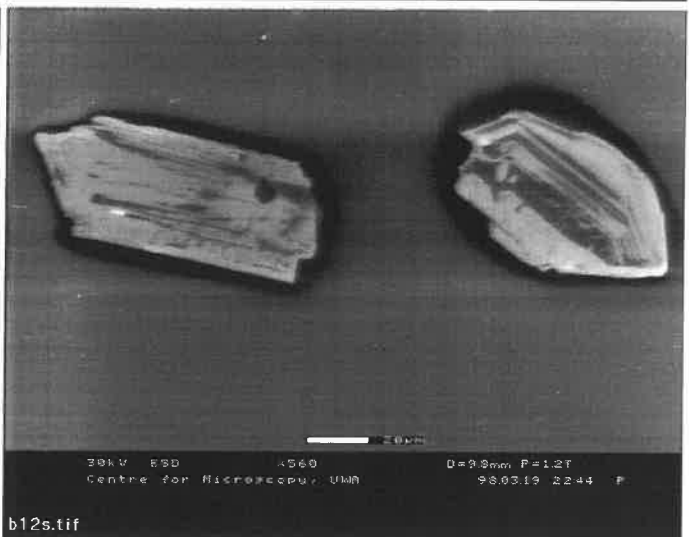
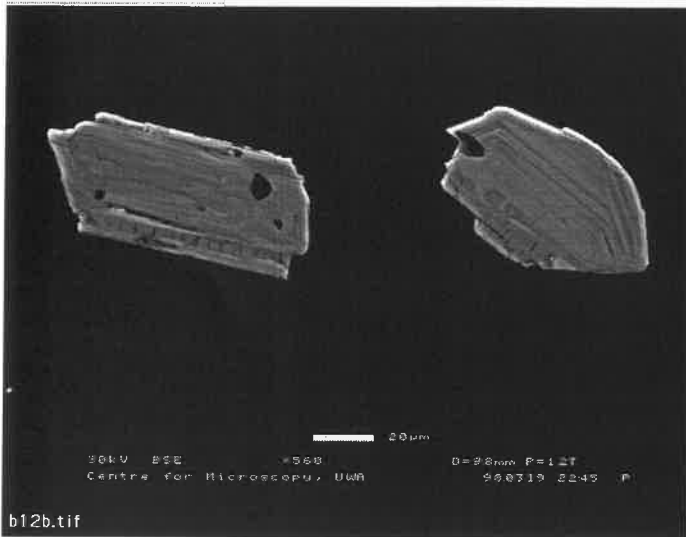
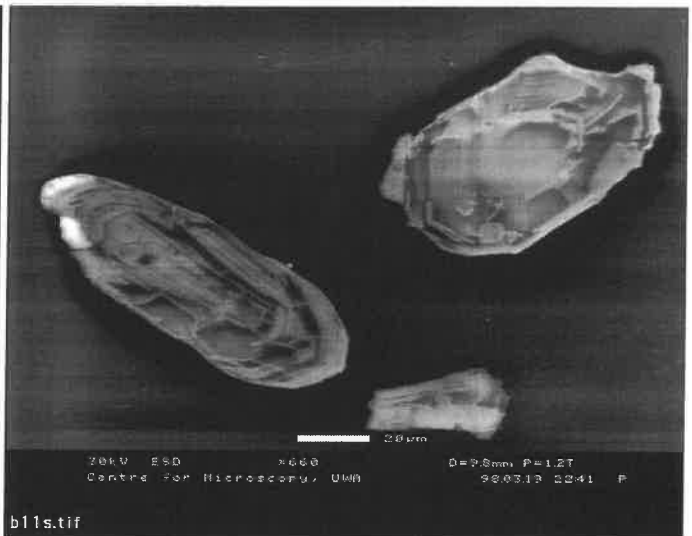
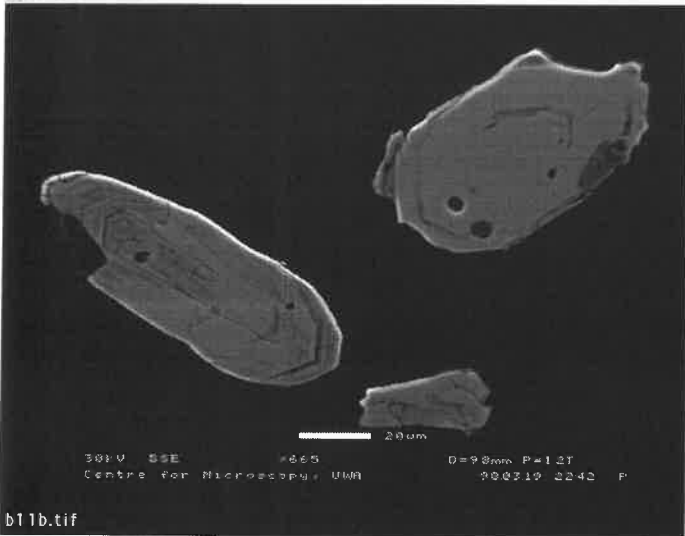
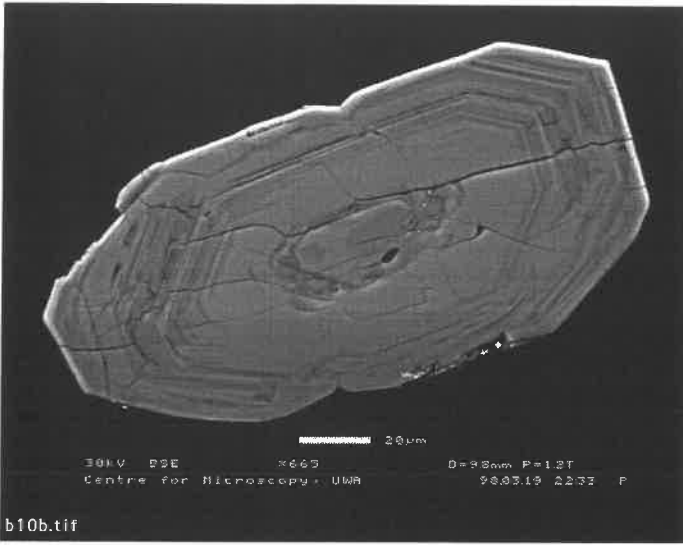
Mount 97-40, Population B (2) 20. 3.98



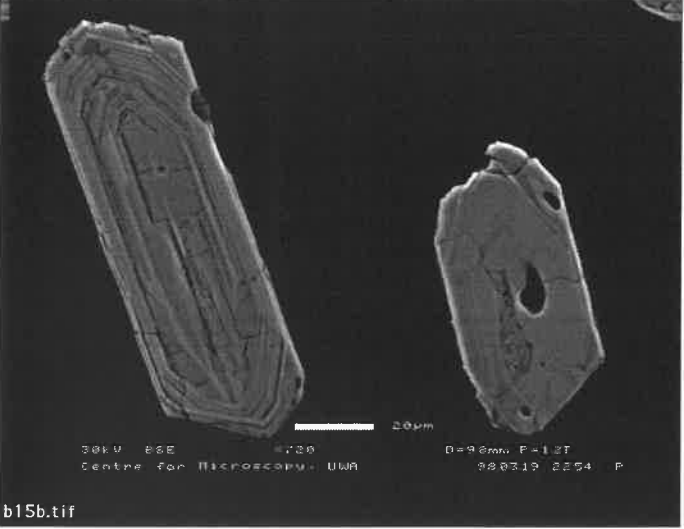
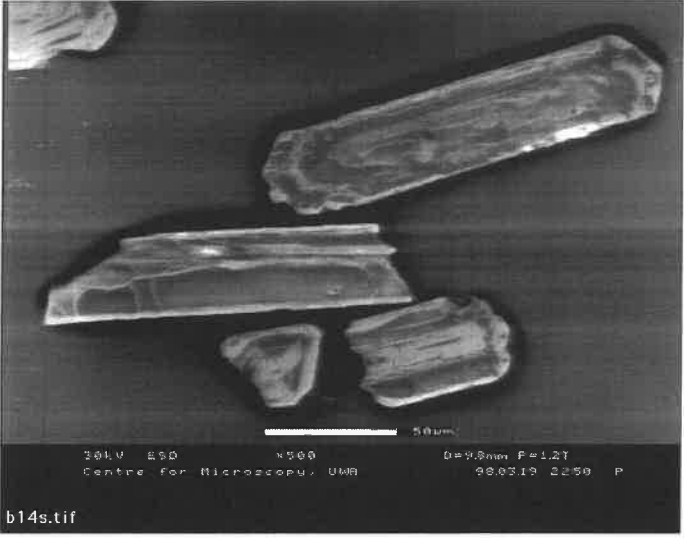
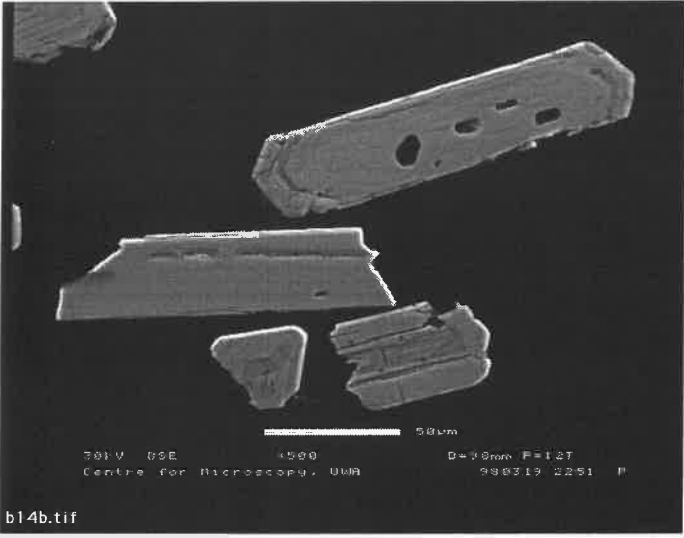
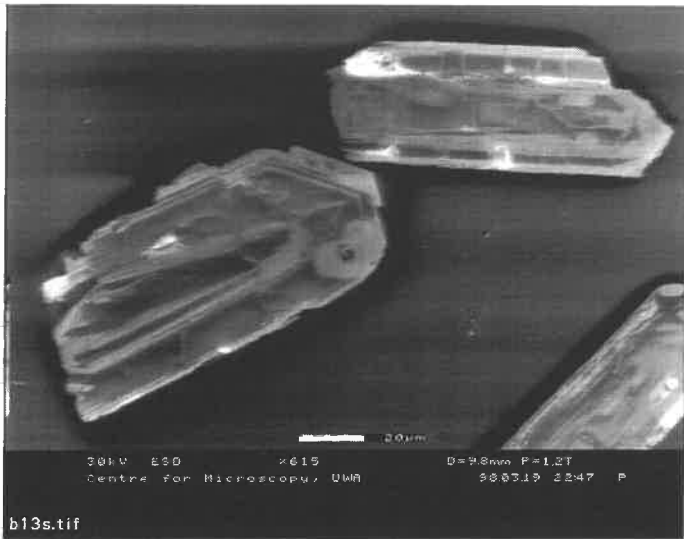
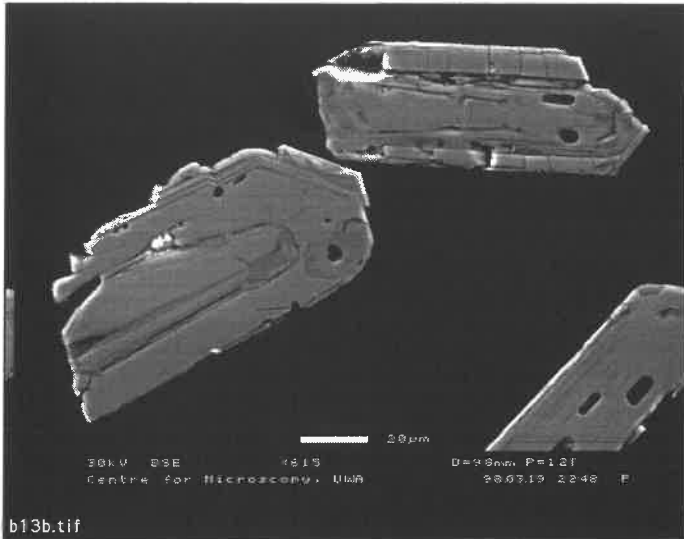
Mount 97-40, Population B (3) 20. 3.98



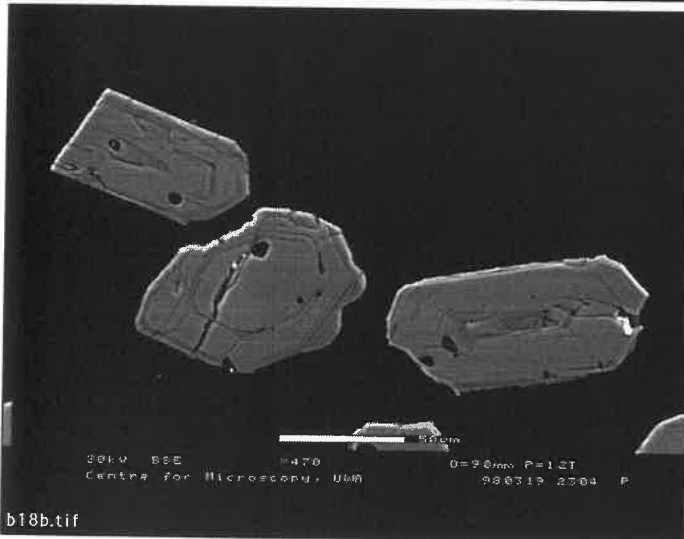
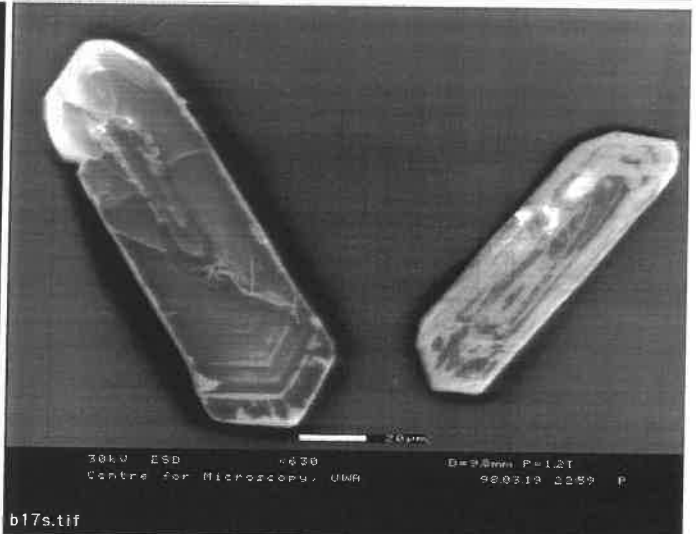
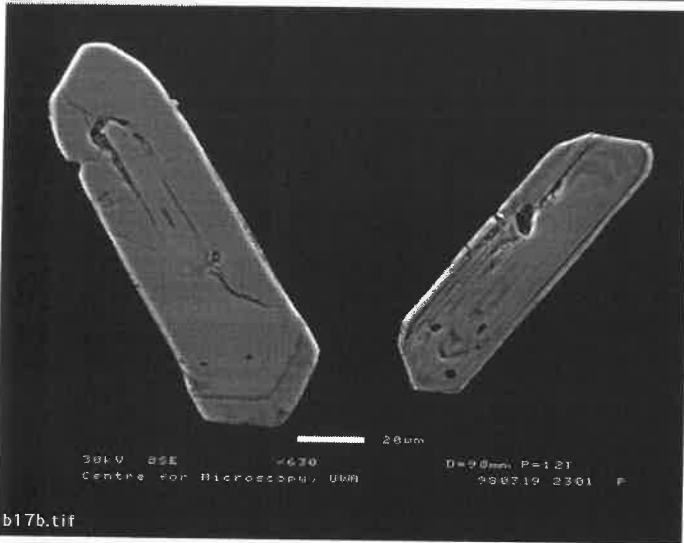
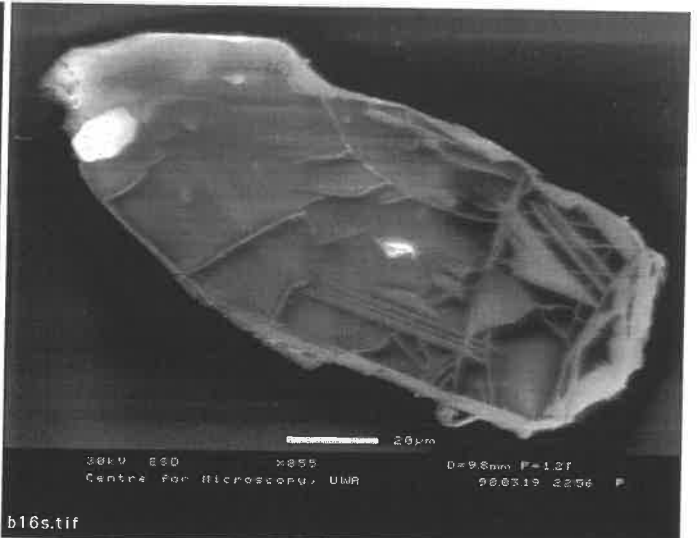
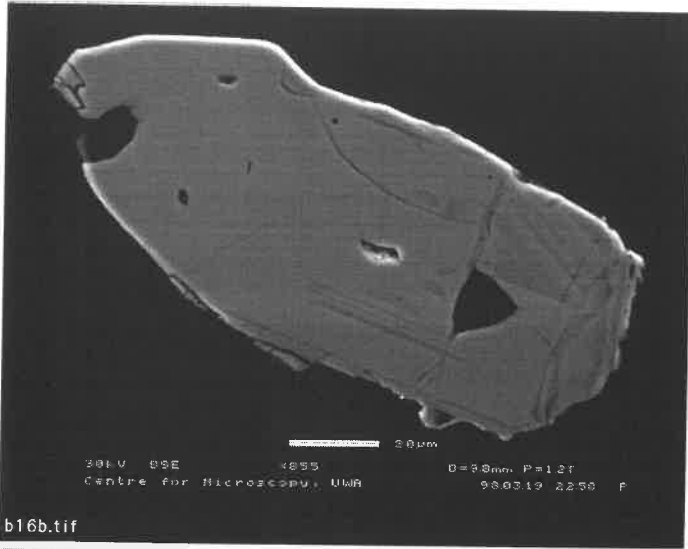
Mount 97-40, Population B (4) 20. 3.98



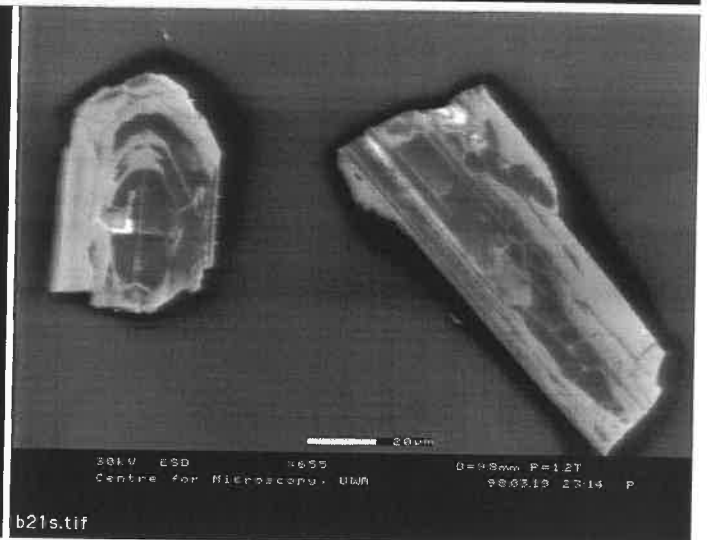
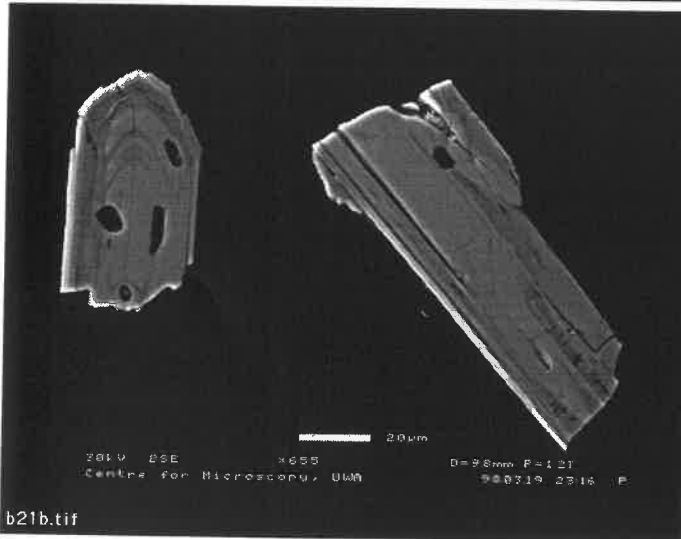
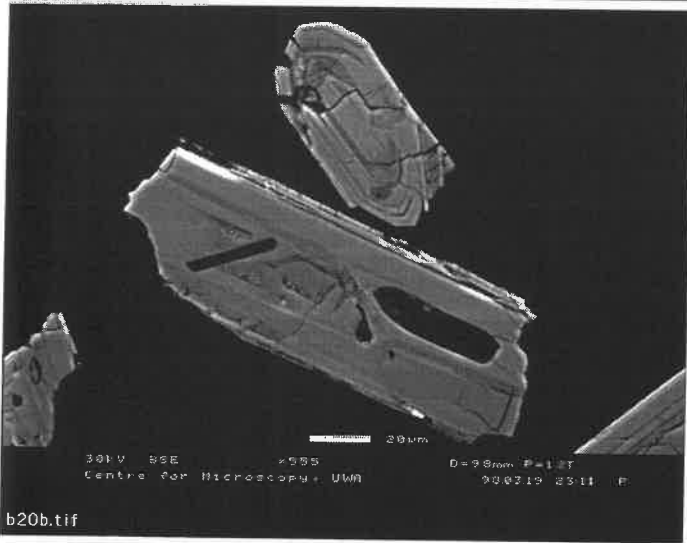
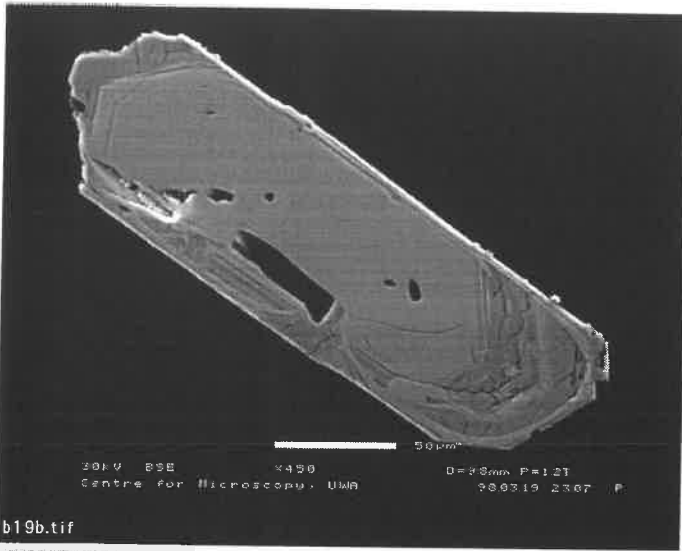
Mount 97-40, Population B (5) 20. 3.98



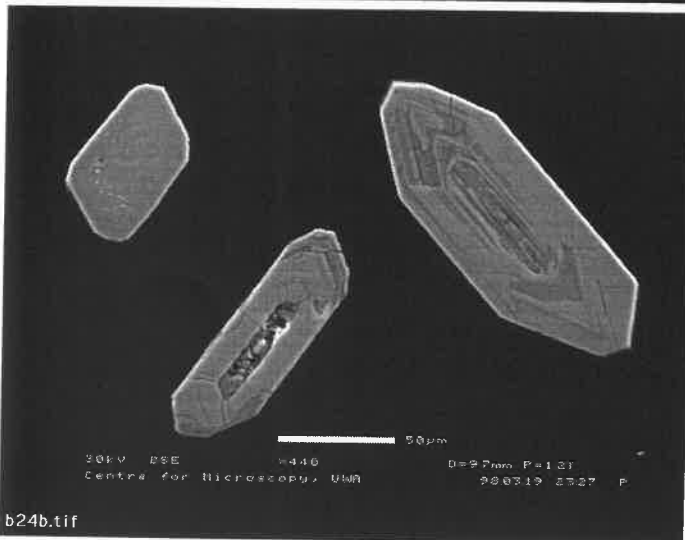
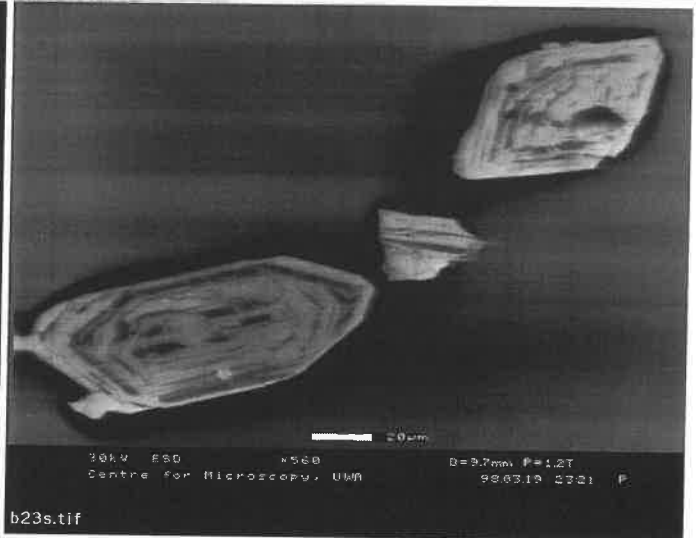
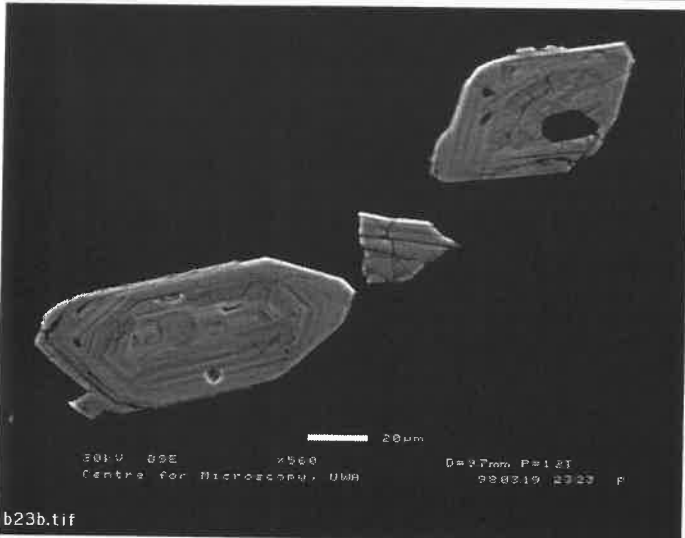
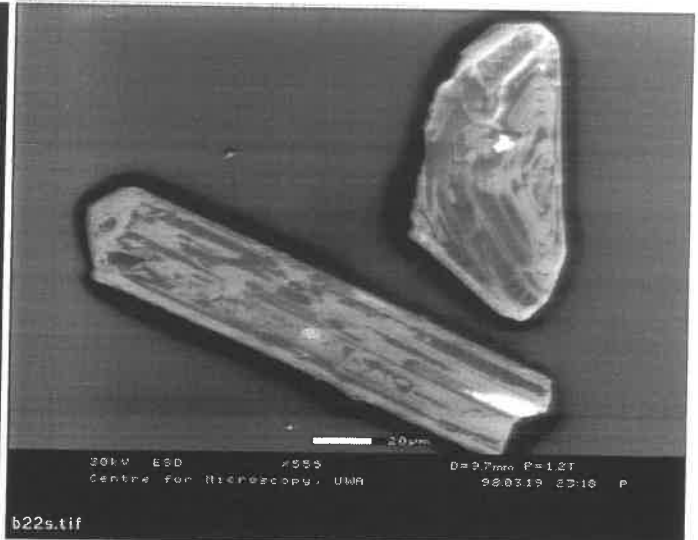
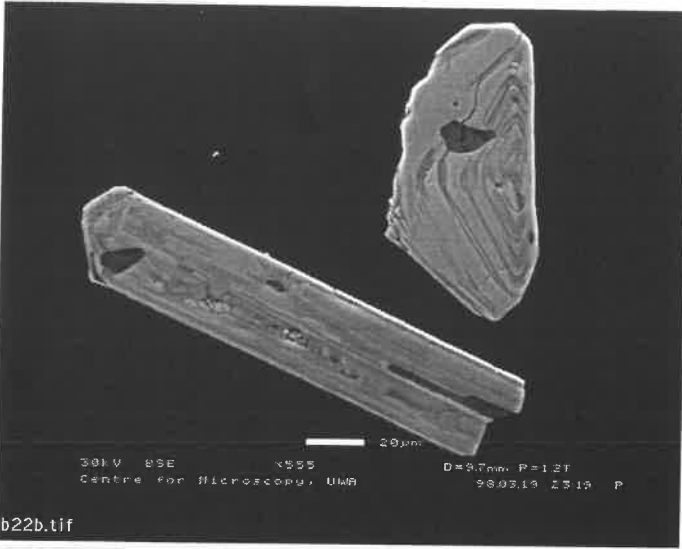
Mount 97-40, Population B (6) 20. 3.98



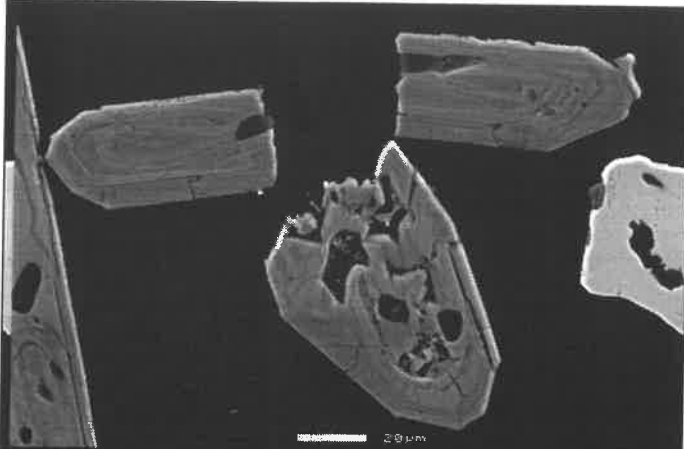
Mount 97-40, Population B (7) 20. 3.98



Mount 97-40, Population B (8) 20. 3.98

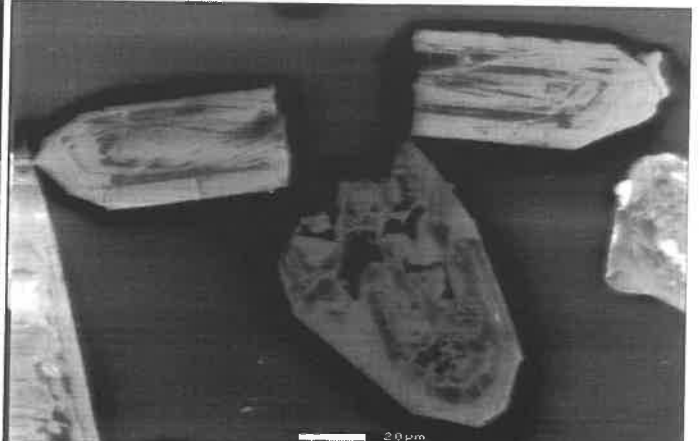


Mount 97-40, Population B (9) 20. 3.98



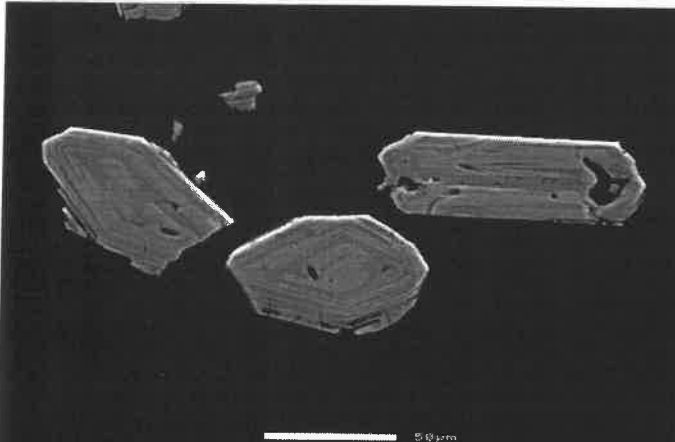
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Centre for Microscopy, UWA 980319 2336 P

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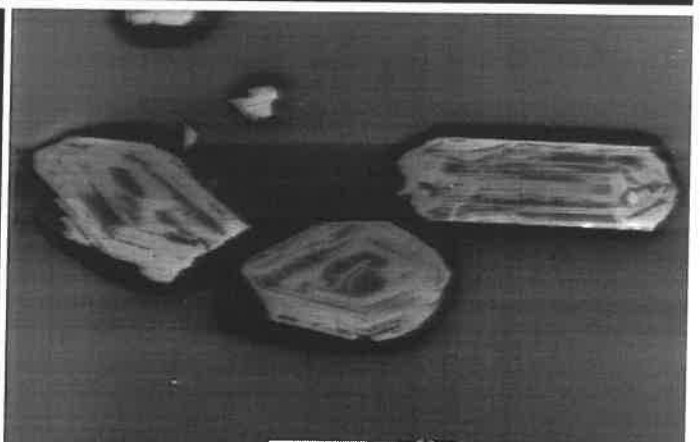
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Centre for Microscopy, UWA 980319 2329 P

b25s.tif



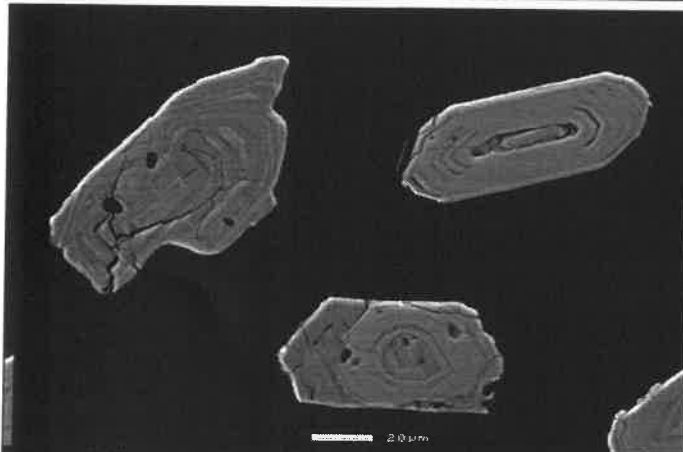
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Centre for Microscopy, UWA 980319 2334 P

b26b.tif



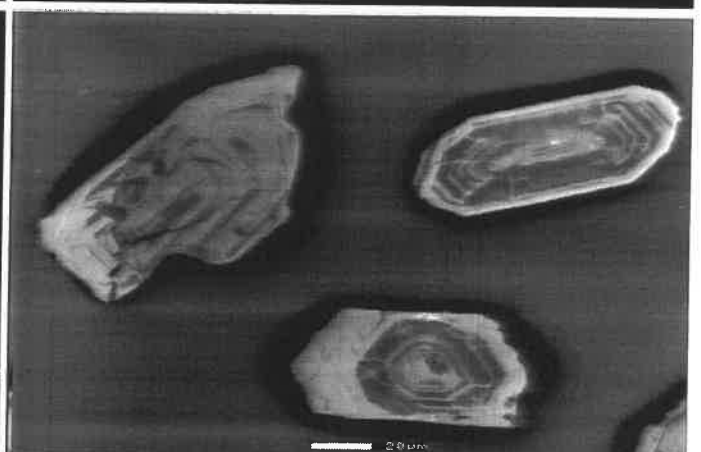
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Centre for Microscopy, UWA 980319 2332 P

b26s.tif



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Centre for Microscopy, UWA 980319 2335 P

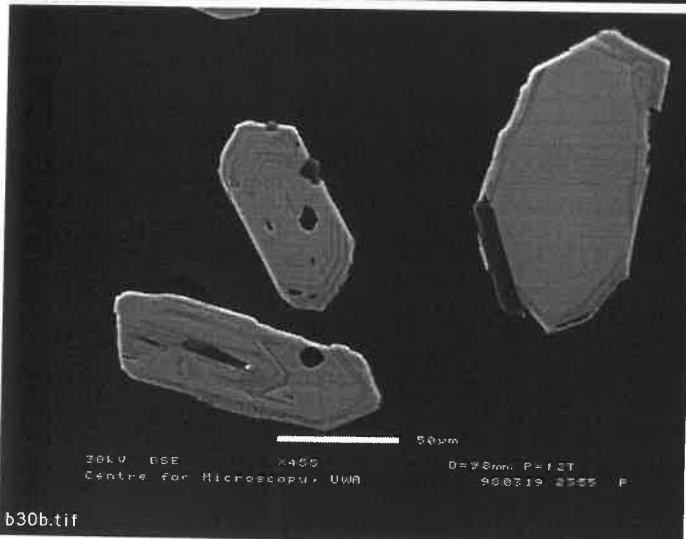
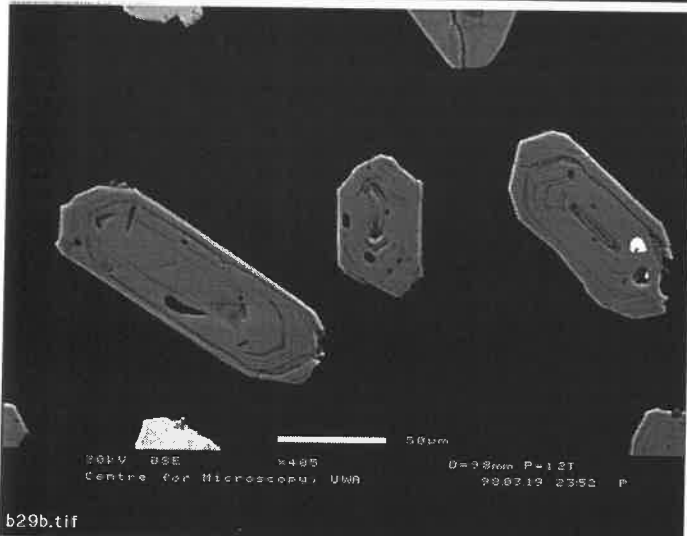
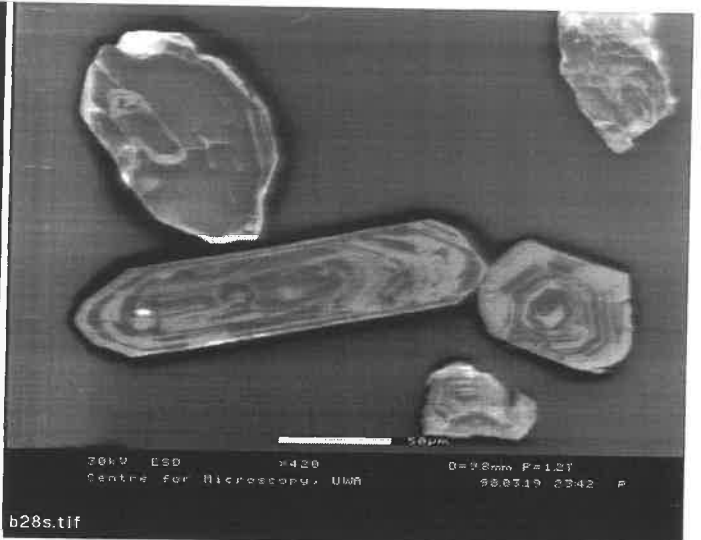
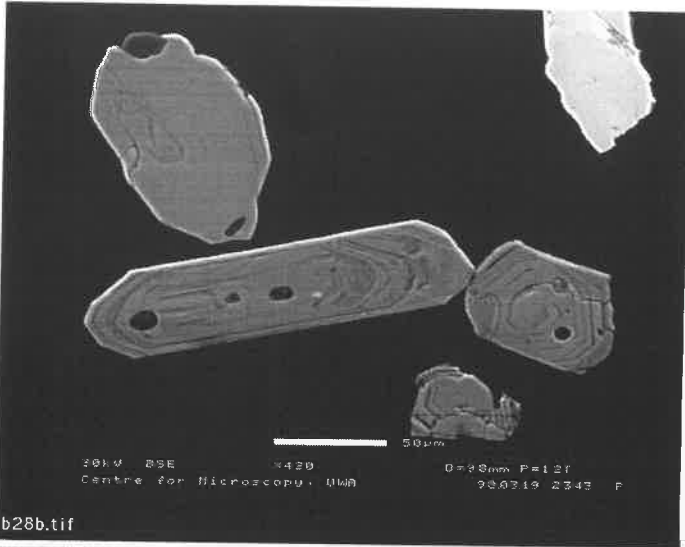
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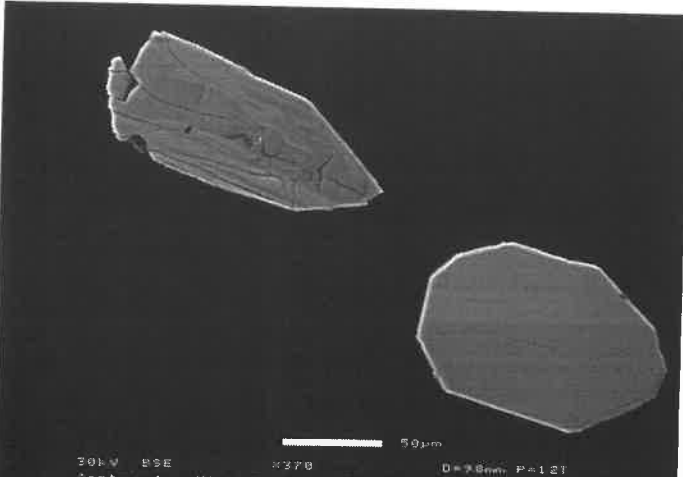
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Centre for Microscopy, UWA 980319 2335 P

b27s.tif

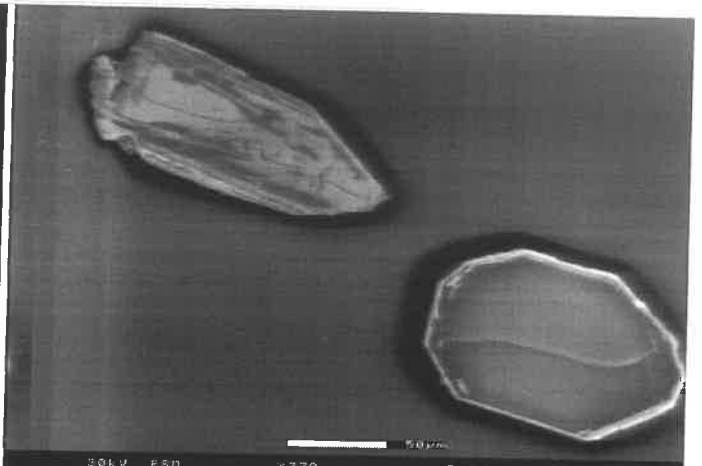
Mount 97-40, Population B (10) 20. 3.98



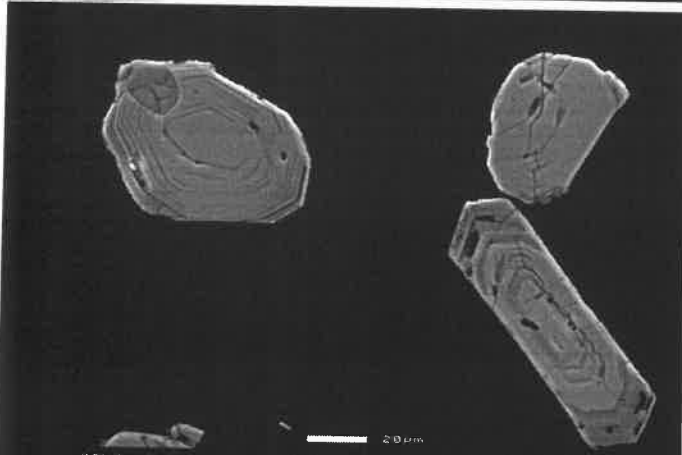
Mount 97-40, Population B (11) 20. 3.98



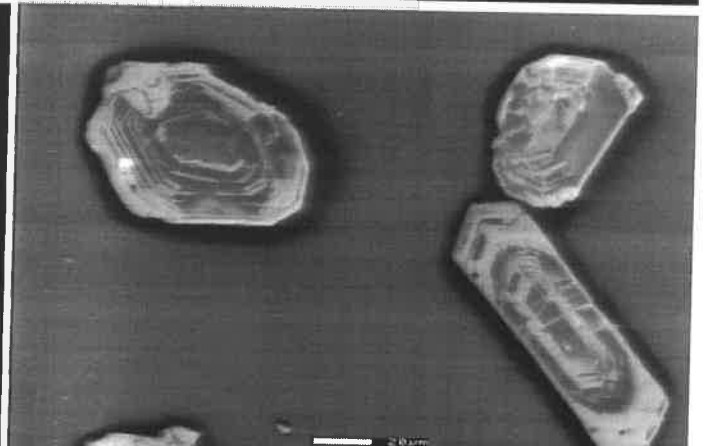
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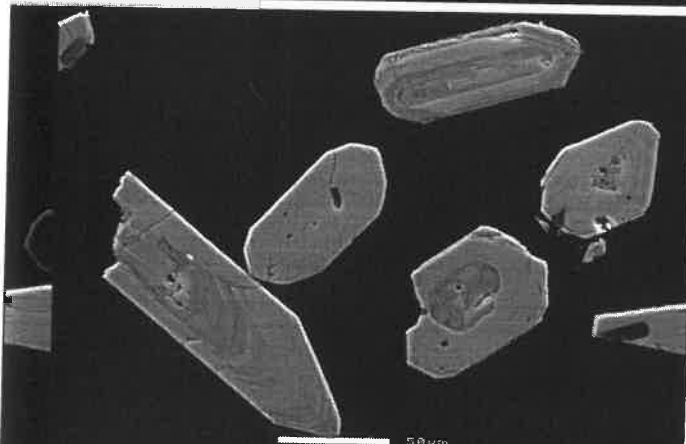
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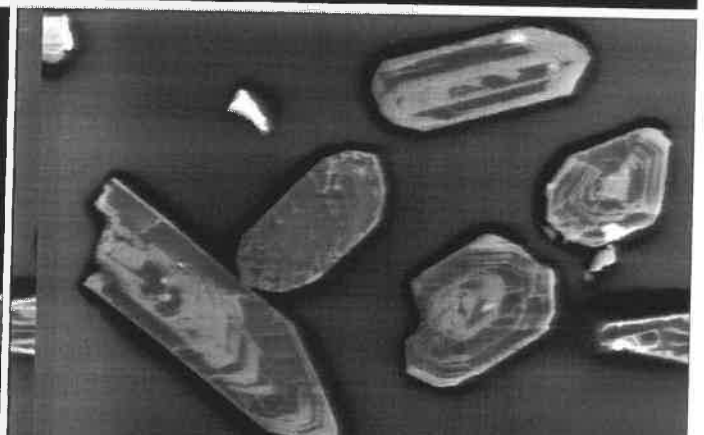
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b32s.tif



b33b.tif



b33s.tif